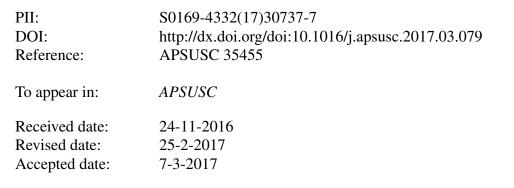
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Please cite this article as: G. Meng, L. Jiang, X. Li, Y. Xu, X. Shi, R. Yan, Y. Lu, Dual-scale nanoripple/nanoparticle-covered microspikes on silicon by femtosecond double pulse train irradiation in water, *Applied Surface Science* (2017), http://dx.doi.org/10.1016/j.apsusc.2017.03.079

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ACCEPTED MANUSCRIPT

Dual-scale nanoripple/nanoparticle-covered microspikes on silicon by femtosecond double pulse train irradiation in water

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